## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s)

Volker BECKER et al.

Serial No.

To Be Assigned

Filed

Herewith

For

DEVICE AND METHOD FOR ETCHING A

SUBSTRATE USING AN INDUCTIVELY #6/12 . A

COUPLED PLASMA

Examiner

To Be Assigned

Art Unit

To Be Assigned

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

## PRELIMINARY AMENDMENT

SIR:

Kindly amend the above-identified application before examination as set forth below.

IN THE SPECIFICATION:

On page 1, line 5, insert: -- FIELD OF THE INVENTION--.

On page 1, line 11, delete "Background Information" and insert:

-- DESCRIPTION OF RELATED ART--.

On page 3, line 7, delete "Advantages of the Invention" and insert:

--SUMMARY OF THE INVENTION-- .

On page 7, line 7, delete "Drawings" and insert:

BRIEF DESCRIPTION OF THE DRAWINGS--.

Page 7, line 26, delete "Exemplary Embodiments" and insert:

DETAILED DESCRIPTION OF THE INVENTION ---.

NY01 342950 v 1

Exp. Hal Ro. EL 234 413077 US